

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Chan-Yong Park  
Appl. No. : 10/802,593  
Filed : March 17, 2004  
For : PHOTO-DIODE HAVING A  
HIGH CHARGE DENSITY  
PORTION IN A FIELD  
CONTROLLING LAYER AND  
METHOD FOR FABRICATING  
THE SAME (as amended)  
Examiner : Thomas L. Dickey  
Group Art Unit : 2826

## CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

September 19, 2005

(Date)

Mincheol Kim, Reg. No. 51,306

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action mailed March 18, 2005 in the above-identified application. Applicant submits the following items for consideration in connection with the application.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.

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